03560.002157.1



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of:	,	Examiner: NYA
MASAFUMI SANO ET AL.)	
Application No.: 10/046,903	:	Group Art Unit: 1741
Application No.: 10/040,903	:	
Filed: January 17, 2002)	
For: METHOD OF PRODUCING ZINC)	
OXIDE THIN FILM, METHOD OF	:	
PRODUCING PHOTOVOLTAIC)	
DEVICE AND METHOD OF	:	
PRODUCING SEMICONDUCTOR)	
DEVICE	:	May 21, 2002
Office of Initial Patent Examination		DECI

Office of Initial Patent Examination Customer Service Center Commissioner for Patents Washington, D.C. 20231 RECEIVED

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TC 1700

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application wherein an error has been noted. The Title is incorrect and should read:

- -Method of producing zinc oxide **thin film**, method of producing **photovoltaic** device and method of producing semiconductor device- -.

A copy of the official Filing Receipt is attached with the proposed changes marked in red. Issuance of a Corrected Filing Receipt with the correct data is accordingly respectfully requested.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No.

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GRP ART UNIT FIL FEE REC'D ATTY.DOCKET.NO IND CLAIMS DRAWINGS TOT CLAIMS APPLICATION NUMBER FILING DATE 03560.002157 01/17/2002 1741 2396 13 42 18 10/046,903 D1

03560,002157 \$1 CONFIRMATION NO. 3549

FILING RECEIPT

MAY 2 3 2000

OC000000007498030

5514 FITZPATRICK CELLA HARPER & SCINTO 30 ROCKEFELLER PLAZA NEW YORK, NY 10112

Date Mailed: 02/20/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Masafumi Sano, Kyoto-fu, JAPAN; Yuichi Sonoda, Nara-shi, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A DIV OF 09/074,699 05/08/1998 PAT 6.346.184 * (*) Data inconsistent with PTO records.

Foreign Applications

JAPAN 1997-121921 05/13/1997

If Required, Foreign Filing License Granted 02/19/2002

Projected Publication Date: 05/30/2002

Non-Publication Request: No

Early Publication Request: No

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Title

thin film,

photovoltaic

Method of producing zinc oxide then film method of producing photovetais device and method of producing semiconductor device

Preliminary Class





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